

FORM PTO-1449
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.: ST9903aSERIAL NO. 09/890,656

LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

APPLICANT: Reinhard Schauer et al.FILING DATE August 2, 2001GROUP: 2811

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

TT	AR		<u>SZE, S.M.: Physics of Semiconductor Devices, New York, Wiley, 1969, p. 43</u>
TT	AS		<u>Ohshita, Y. et al; Journal of Crystal Growth, 1991, vol. 108, pp. 499-507</u>
TT	AT		<u>Hammond, M.L.: Silicon Epitaxy, Solid State Technology, 1978, H. 11, pp. 68-75</u>

EXAMINER

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DATE CONSIDERED

01-08-03

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 602; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.